Search Notes

_	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/699,117	PARK ET AL.	
	Examiner	Art Unit	
	Tae H. Yoon	1714	

OFAROUER						
SEARCHED						
Class	Subclass	Date	Examiner			
523	116	1-13-06	N			
	120					

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST	1-13-06	ny		
Inventor Search	1-21-06	y		
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